

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/780,761	OKUDA, TATSUO	
Examiner	Art Unit	
YOGESH K. AGGARWAL	2622	

SEARCHED					
Class	Subclass	Date	Examiner		

INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
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SEARCH N (INCLUDING SEARC)
	DATE	EXMR
References used from IDS	5/26/2008	YKA